

Serial No.: 10/573,446
Docket No.: 04-41PUS
EBI.053



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Lin Hai, et al.

Serial No.: 10/573,446

Group Art Unit: 2879

Filing Date: March 24, 2006

Examiner: Thomas A. Hollweg

For: PLASMA DISPLAY PANEL AND METHOD OF MANUFACTURING SAME

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following documents listed on a European Search Report issued in a counterpart foreign application, dated February 27, 2009 and the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Additionally, English language abstracts of the references are included herewith.

This citation does not constitute an admission that the reference is relevant or material to the claims. It is only cited as constituting related art of which applicants are aware.

In compliance with the requirements of 37 CFR §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 35 U.S.C. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the reference was cited in a related application on related subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the application under the laws of that country or the United States relative to the subject matter claimed in the present application has been

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made, the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of that item by a foreign patent office in a counterpart foreign application, which occurred not more than three months prior to the filing of this statement.


Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application and that this communication was not received by any individual designated in §1.56(c) more than thirty days prior to the filing of this Information Disclosure Statement (37 C.F.R. §1.704(d)).

Submitted herewith is a check in the amount of \$180.00 to cover the IDS fee.

It is respectfully requested that the listed reference be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,


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Date: March 26, 2009
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